



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Kikuchi et al.

Application No. 10/635,661

Filed: August 5, 2003

Confirmation No. 8882

For: RETICLE MANIPULATORS AND
RELATED METHODS FOR CONVEYING
THIN, CIRCULAR RETICLES AS USED
IN CHARGED-PARTICLE-BEAM
MICROLITHOGRAPHY

Examiner: Della J. Rutledge

Art Unit: 2851

Attorney Reference No. 4641-65956-01

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: MAIL STOP AMENDMENT
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Attorney
for Applicant(s)

Donald L. Stenberg

Date Mailed January 21, 2005

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AMENDMENT AND REPLY TO OFFICE ACTION

This paper is submitted in reply to the Office action dated October 5, 2004. Please amend the subject application as follows:

Amendments to the Abstract begin on page 2.

Amendments to the Specification begin on page 3.

Amendments to the Drawings begin on page 4.

Remarks begin on page 5.